

(Use several sheets if necessary)

Application No.:  
**10/518,080**

**Filing Date:**  
**December 16, 2004**

Group Art Unit:

## U.S. PATENT DOCUMENTS

[illegible]

## FOREIGN PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
/CMK/	WO 9011066 (corresponding to SE463493)	10/4/1990	WIPO				
/CMK/	EP 0559627 (corresponding to SE 502987)	9/8/1993	EPO				
/CMK/	WO 00/21489	4/20/2000	WIPO				
/CMK/	WO 01/76534	10/18/2001	WIPO				
/CMK/	WO 01/76535	10/18/2001	WIPO				

**OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)**


**EXAMINER:**

**/C. Melissa Koślow/**

DATE CONSIDERED

11/01/2007

**EXAMINER:** Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

\* Abstract provided for the Examiner's convenience

# INFORMATION DISCLOSURE CITATION IN AN APPLICATION

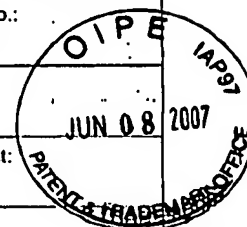
(Use several sheets if necessary)

 Attorney Docket No.:  
**1510-1098**

 Application No.:  
**10/518,080**

 Applicant:  
**Leif HERMANSSON et al.**

 Filing Date:  
**September 29, 2005**

 Group Art Unit:  
**1755**


## U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing date (if appropriate)
/CMK/	4,362,242	12/07/82	Cheetham			
/CMK/	4,182,447	1/8/80	Kay			

## FOREIGN PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)


EXAMINER:

/C. Melissa Koslow/

DATE CONSIDERED

11/01/2007

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

\* Abstract provided for the Examiner's convenience